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Influence of a depletion layer on localized surface waves in doped semiconductor nanostructures

S. Vassant,^{1,2,a)} F. Pardo,¹ P. Bouchon,³ R. Haïdar,³ F. Marquier,² J. J. Greffet,² and J. L. Pelouard¹

¹Laboratoire de Photonique et Nanostructures (LPN-CNRS), Route de Nozay, F-91460 Marcoussis, France ²Laboratoire Charles Fabry, Institut d'Optique, CNRS, Univ. Paris-Sud, 2 avenue Augustin Fresnel, 91127 Palaiseau cedex, France

³ONERA - The French Aerospace Lab, F-91761 Palaiseau, France

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We report THz polarized reflectivity measurements on a doped GaAs grating made of thin walls with subwavelength dimensions and periodicity. A clear dip appears in the TM-polarized reflectivity spectrum, due to the excitation of a localized surface plasmon-phonon mode along the grating walls. The theoretical model used to describe the electromagnetic response of the grating shows the importance of the depletion layer at the GaAs surface and indicates a high sensitivity of the reflectivity dip frequency to the surface potential. © 2012 American Institute of Physics. [http://dx.doi.org/10.1063/1.3689747]

With the increasing research activity in the THz field, there is a renewed interest in surface waves supported by semiconductors (SCs). Two types of surface waves can propagate on a SC: surface phonons polaritons (SPhP) in the reststrahlen band for polar SC and surface plasmons polaritons (SPP) if the SC (polar and not polar) is doped. When the electron plasma frequency in the SC is close to the optical phonon frequencies, both surface waves couple leading to surface plasmon-phonon polaritons (SPPhP).¹ Since the seventies, theoretical studies² have predicted that the propagation of surface waves could be modified by the presence of a depletion or accumulation layer at the SC/air interface. For example, in the case of GaAs, the crystal symmetry breaking at the surface creates a distribution of levels in the gap of the SC that lead to the pinning of the Fermi level.³ This entails the formation of a carrier-depleted layer at the GaAs surface. From Ref. 2, the influence of this layer on surface waves is expected only at large wavevectors. Thus, most of the experimental efforts have been focused on electron energy loss spectroscopy to observe the effect of depletion (and accumulation) layers in SCs on surface waves (see Ref. 4 for example).

The influence of the depletion layer on optical measurements has been explored by infrared ellipsometry on flat surfaces (see Ref. 5 and reference therein), but there are only a few studies concerning structurated SC supporting surface waves. The reflectivity of doped SC structurated surfaces was measured in the seventies^{6,7} without reliable results because fabrication techniques were not as developed as nowadays. Both in Refs. 6 and 7, the fabrication process damaged the sample surface and the geometries of the samples were not well known. A depletion layer was invoked to explain discrepancies between experimental and theoretical results. Other studies can be found, where the transmission of small crystals embedded in a matrix is measured. Rieder *et al.* studied SPPhP modes of CdO microcystals⁸ and noted that an hypothetical non-uniform electron distribution in the crystals could have an effect on the spectra. Later, a coreshell model was proposed by Yamamoto *et al.*,⁹ giving a qualitative agreement with the measurements of doped GaAs micro-crystals. However their size was not uniform and the shell thickness was only a phenomenological parameter, unrelated to the surface potential.

In this paper, we report experimental results on a lamellar doped SC grating made of parallel thin walls. Each wall has a width of the order of a few depletion layer thicknesses. TM-polarized reflectivity measurements show a dip that is due to the excitation of localized SPPhP modes. Comparison with theory indicates that the depletion layer has to be taken into account to fit the data. This dependance can be used to measure optically surface potential changes.

The geometry of the fabricated grating is schematically shown in Fig. 1(a). The fabrication process is the same as the first steps of Ref. 10. The grating lines are defined by e-beam lithography, followed by a Ti/Ni metallization and a lift-off. The metallic lines then serve as a mask for an inductively coupled plasma reactive ion etching with BCl₃, Cl₂, and Ar gases. The metallic mask is then removed in a diluted HF solution.



FIG. 1. (Color online) (a) Schematic view of the grating with a TM polarized incident field. (b) Scanning electron microscope images of the fabricated n-GaAs grating.

^{a)}Author to whom correspondence should be addressed. Electronic mail: simon.vassant@institutoptique.fr.

The etching process is strongly anisotropic as shown in the scanning electron microscope (SEM) cross-section images in Fig. 1(b). The grating period Λ is 2.5 μ m. From SEM pictures, we measure the wall width (W = 85 nm) and height (h = 860 nm).

The sample was placed in a Brucker Vertex 70 Fourier transform infrared spectrometer (FTIR), purged with dry air, equiped with an A-513Q reflectometry instrument, and a THz polarizer (Tydex). Reflectivity references were taken on a gold mirror (Ti/Au, 20/200 nm) deposited on the sample next to the grating. We used a HeNe laser beam impinging on the grating ensures the setup alignment: the observation of -1, 0, and +1 diffraction orders allowed to define the plane of incidence with a precision of 3 mrad.

Reflectivity spectra of the sample (flat surface and grating) are measured in TM and TE polarization for different incident angles θ_i (Fig. 2).

All curves in Fig. 2 show a dip at 39.1 μ m. This corresponds to an effect of the transverse optical phonon of GaAs on the dielectric function. A dip is observed in the reflectivity at 35.3 μ m, only if the incident light is TM polarized. Its frequency does not change with incident angle, whereas its amplitude increases from 0.85 at $\theta_i = 15^\circ$ (limit of the setup) to 0.41 at $\theta_i = 50^\circ$. Note that at the same wavelength the reflectivity of the flat surface is 0.9 at $\theta_i = 45^\circ$. The angular independence of the dip position indicates that we have observed a localized resonance. As detailed in the next section, the real part of the dielectric function of n-doped GaAs is negative at 35.3 μ m due to optical phonon resonances of the polar lattice and free electron contribution. Hence, we attribute the 35.3 μ m absorption dip to the excitation of a localized SPPhP.

To confirm this hypothesis, we performed numerical simulations of the reflectivity spectrum using a rigorous maxwell calculation with constitutive approximation code (RMCA).¹¹ This method allows using an adaptative mesh to describe the structure which is very appropriate to precisely mesh the thin grating walls. To describe the doped GaAs optical behavior, we use the following dielectric function:¹²

$$\epsilon(\omega) = \epsilon_{\infty} (1 - \eta_{\rm ph} - \eta_e), \tag{1}$$



FIG. 2. (Color online) Experimental reflectivity spectra of the sample (flat surface and grating) measured at various angles of incidence in TM and TE polarization.

$$\begin{split} \eta_{\rm ph} = & \frac{\omega_L^2 - \omega_T^2}{\omega^2 - \omega_T^2 + i\Gamma\omega}, \\ \eta_e = & \frac{\omega_p^2}{\omega^2 + i\Gamma_e\omega}, \end{split}$$

where $\eta_{\rm ph}$ corresponds to the polar lattice contribution and η_e to the free electrons contribution. The frequencies ω_T and ω_L correspond, respectively, to the transverse and longitudinal optical phonons of the SC, Γ , and Γ_e are the damping factors, respectively for phonons and electrons. The plasma frequency ω_p is given by $\omega_p^2 = N_D e^2 / \epsilon_0 \epsilon_\infty m^*, N_D$ is the electron density, *e* the electron charge, ϵ_∞ the high frequency dielectric constant of the SC, ϵ_0 the vacuum permittivity, and m^* the effective electronic mass. The phonon parameters ($\omega_L, \omega_T, \Gamma$) were taken from the litterature.¹³ The carrier density N_D and Γ_e are determined by fitting a spectrum measured on the flat GaAs surface. We obtain $N_D = (1.47 \pm 0.01) \times 10^{18} \text{ cm}^{-3}$ and $\Gamma_e = (69.5 \pm 0.1) \text{ cm}^{-1}$. As shown in a previous work,¹⁴ we have to take into account the curvature at the bottom of the structure due to the etching process (see Fig. 1(b)).

To compare the measurements with simulations, we start by considering two limiting cases: (1) the walls are uniformly occupied by electrons, i.e., without a depletion layer (Fig. 3(a)) and (2) the walls are fully depleted (Fig. 3(b)).

In the first case (Fig. 3(a)), the dip at 35.3 μ m is reproduced in the simulation, but with a large shift towards lower wavelengths and a much broader shape. In the second case (Fig. 3(b)), the dip at 35.3 μ m is again observed, but with a shift towards higher wavelength and a decrease in width. In



FIG. 3. (Color online) Comparison of the measured reflectivity of the GaAs grating ($\theta_i = 45^\circ$, TM polarized) with the theoretical reflectivity obtained with three models: (a) walls uniformly filled with electrons, (b) fully depeleted walls, and (c) "core-shell" model.



FIG. 4. Real part of the electric field along the *x* direction at 35.3 μ m for $\theta_i = 45^{\circ}$ and TM-polarization. One period is shown. The black line indicates the surface of the grating.

both cases, no satisfying agreement can be found by changing the geometric parameters in the limit of the SEM measurement precision ($\pm 10\%$).

We now consider a "core-shell" model as illustrated in Fig. 3(c), to take into account the depletion layer originating from the Fermi level pinning at the GaAs surface. We use the approximation of complete depletion to calculate the thickness *d* of the shell: $d = \sqrt{2V_s \epsilon_0 \epsilon_{\text{stat}}/eN_D}$, where ϵ_{stat} is the static dielectric constant of the SC and V_s the surface potential. For GaAs, V_s is known to be relatively constant at 0.7 eV,³ giving $d \approx 26$ nm for an electron density of $1.47 \times 10^{18} \text{ cm}^{-3}$. The inner part of the wall has a dielectric constant given by Eq. (1) with N_D and Γ_e parameters identical to those of the substrate, while the outer shell is composed of fully depleted GaAs. With this model, we get an excellent agreement between theoretical and experimental reflectivities at $\theta_i = 45^\circ$ (Fig. 3(c)) and for all the angles between 15° and 50° (not shown).

Using these extracted parameters at 35.3 μ m, we have calculated the near field distribution in the structure to understand the nature of the mode excited in the grating. As seen on Fig. 4, the electric field is strongly concentrated along the vertical walls. Thus, the coupling between the walls is negligible. We can consider each wall of the grating as a nanoantenna. This agrees with the experimentally observed angular independence of the reflectivity dip frequency. The electric field component E_x is replace antisymetric by antisymmetric and is similar to the short-range SPP mode supported by a thin metallic slab.¹⁵ This mode cannot be excited at normal incidence, and the coupling is an increasing function of the angle θ_i . This explains our experimental observation of the dip amplitude variation with this angle. The short range SPP is known to have a noticeably larger effective index than those of the surrounding dielectric due to the coupling of two SPP through the metallic thin film. Here, the coupling of two SPPhP through a 85 nm thick wall leads to an increase of the effective index $n_{\rm eff}$ by a factor close to seven. From our calculations we obtain $n_{\rm eff} = 7.54 + 2.17i$ whereas the effective index for a flat interface separating air from undoped GaAs is 1.092 + 0.026i and 1.016 + 0.004i for doped GaAs. Since each wall of the grating acts as a resonant nanoantenna, the resonant wavelength λ_r is determined by the antenna length (here, the grating height *h*). As the geometry is similar to a ground-plane antenna, we expect a $\lambda/4$ resonant behaviour. In fact, we obtain $\lambda_r = 5.44hn_{\text{eff}}$ which can be explained by dephasing upon reflection at the bottom and top of the wall.

Finally, we evaluate the sensitivity of the SPPhP frequency to the model parameters. Changing the surface potential by ± 25 meV produces a frequency shift of the reflectivity dip of ± 25 nm, while its amplitude remains unchanged. A variation of only 1 nm in W induces a shift of the resonance wavelength of about 34 nm, while the amplitude is kept at the same value. The height of the grating has a lower influence compared to surface potential and wall thickness. A 1 nm variation in height h induces both wavelength and amplitude changes of, respectively, 1.4 nm and 0.5%. All these modifications only affect the reflectivity dip due to the SPPhP and do not alter the rest of the spectrum. The shape of the resonance itself is also preserved. These shifts can be measured by common FTIR techniques which mean that THz reflectivity on structurated polar materials can be used as a non-destructive method to probe surface potential variations.

To summarize, we studied by FTIR polarized reflectivity measurements localized SPPhPs on a one dimensional grating with very small wall widths. We have shown that the surface depletion layer plays an important role in the electromagnetic response of the grating. The introduction of a "core-shell" model allows a good description of the electromagnetic response of the grating. Using this model, it is possible to extract surface potential variations from the spectral reflectivity shifts with an accuracy of tens of meV, which can be used for biosensing or surface chemistry studies.

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